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Dated: April 25, 2005

Signature: 

(Michael R. Hull)

Docket No.: 29936/39474  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Cha Deok Dong et al.

Application No.: 10/617,476

Confirmation No.: 3456

Filed: July 11, 2003

Art Unit: 2829

For: METHOD OF MANUFACTURING A  
SEMICONDUCTOR DEVICE

Examiner: C. P. Chaudhari

**AMENDMENT AFTER FINAL ACTION (37 C.F.R. SECTION 1.116)**

MS AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**INTRODUCTORY COMMENTS**

In response to the Office Action dated March 2, 2005, finally rejecting claims 1-11, and allowing claims 12-16, please amend the above-identified U.S. patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.